JAN 2 1 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Gosain, Dharam Pal, et al.

Serial No.: 10/645,805

Filed: August 21, 2003

For: METHOD OF PRODUCING
CRYSTALLINE SEMICONDUCTOR
MATERIAL AND METHOD OF
FABRICATING SEMICONDUCTOR
DEVICE

Case No.: 09792909-5657

Examiner: Schillinger, L. M.

Group Art Unit: 2813

Confirmation No. 8039

Certificate of Mailing (37 CFR 1.8(a))

I hereby certify that this correspondence is being sent via U.S. Mail to Examiner L. M. Schillinger, Group Art Unit No. 2813:

Mail Stop After Final Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 on:

Date of Mailing:

, 2006

W. John Keyes

Registration No. 54,218

AMENDMENT B

Mail Stop After Final Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the Final Office Action of November 14, 2005. Applicants respectfully request reconsideration in view of the remarks presented herein.